



PN3

Page 1 of 1

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)	SERIAL NO. 10/009,674	ATTORNEY DOCKET NO. 3142.2.2.8
	FILING DATE December 6, 2001	GROUP ART UNIT
	APPLICANT(S): Michael R. McNeely et al.	

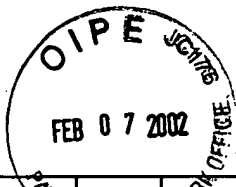
REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
<i>SMA</i>	A1	2002/0046995	04/25/2002	Chang et al.	219/121.69	04/20/2001

EXAMINER <i>S. Heinrich</i>	DATE CONSIDERED <i>01-29-2004</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).



PN 6

Page 2 of 2

EXAMINER INITIAL	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)
SMH	A21 Blanchet, Graciela B., "Deposition of Amorphous Fluoropolymers Thin Films by Laser Ablation," Appl. Phys. Lett. 62 (5), 1 Feb. 1993, 479-81
SMH	A22 Bolle, M., et al., "Photochemically Assisted Laser Ablation of Doped Polymethyl-Methacrylate," Applied Surface Science, 46, (1990), 279-83
SMH	A23 D'Anna, E., et al., "Nitridation of Titanium by Multipulse Excimer Laser Irradiation," Applied Surface Science 46 (1990), 365-70
SMH	A24 Giardini-Guidoni, A., et al., "Luminescence and ESCA Analysis of Laser-Ablated Materials, et al., Applied Surface Science 46 (1990), 321-25
SMH	A25 Hiraoka, Hiroyuki, et al., "Surface Modifications of Kapton and Cured Polyimide Films by ArF Excimer Laser: Application to Imagewise Wetting and Metallization," Applied Surface Science 46 (1990) 264-71
SMH	A26 Kesting, Wolfgang, et al., "Controlled Structuring of Polymer Surfaces by UV-Laser Irradiation," Applied Surface Science 46 (1990) 326-29
SMH	A27 Lazare, Sylvain, et al. "UV-Laser Photoablation of Thermostable Polymers, Polyimides, Polyphenylquinoxaline and Teflon AF," Mat. Res. Soc. Symp. Proc., Vol. 227, 1991 Materials Research Society, 253-58
SMH	A28 Pethig, R., et al., "Development of Biofactory-on-a-chip Technology Using Excimer Laser Micromachining," J. Micromech, Microeng, 8 (1998) 57-63
SMH	A29 Srinivasan, R., et al., "Ultraviolet Laser Ablation and Etching of Polymethyl Methacrylate Sensitized with an Organic Dopant," Appl. Phys. A 45, (1988) 289-92
SMH	A30 Ulmer, G., et al., "Excimer Laser Ablation of Polyimide," Applied Surface Science 46 (1990) 272-78
SMH	A31 Technical Digest from the Pacific Rim Conference on Lasers and Electro-Optics, July 14-18, 1997, IEEE Catalog No.: 97TH9275, Library of Congress 97-70754

EXAMINER S. Heinrich	DATE CONSIDERED 01-29-2004
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PN 6

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	FILING DATE December 6, 2001	GROUP ART UNIT 1725
	APPLICANT(S): Michael R. McNeely et al.	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
SMH	A1	4,150,008	04/17/1979	Vassiliou et al.	260/29.6 F	08/02/1977
SMH	A2	4,405,544	09/20/1983	Solomon	264/127	02/16/1982
SMH	A3	4,808,966	02/28/1989	Ferlier et al.	338/214	08/05/1987
SMH	A4	4,859,836	08/22/1989	Lunk et al.	219/548	08/14/1986
SMH	A5	4,855,018	08/08/1989	Leonard et al.	156/646	07/31/1987
SMH	A6	4,902,378	02/20/1990	Ouderkirk et al.	156/643	04/27/1988
SMH	A7	4,985,296	01/15/1991	Mortimer, Jr.	428/220	03/16/1989
SMH	A8	5,260,175	11/09/1993	Kowanz et al.	430/326	07/25/1991
SMH	A9	5,262,234	11/16/1993	Minor et al.	428/372	07/16/1992
SMH	A10	5,091,284	02/25/1992	Bradfield	420/292	11/08/1988
SMH	A11	5,302,421	04/12/1994	Hoessel et al.	427/552	07/09/1993
SMH	A12	5,302,547	04/12/1994	Wojnarowski et al.	437/173	02/08/1993
SMH	A13	5,320,789	06/14/1994	Nishii et al.	264/22	11/04/1992
SMH	A14	5,482,660	01/09/1996	Yamamoto et al.	264/474	10/30/1992
SMH	A15	5,501,827	03/26/1996	Deeney et al.	264/460	02/08/1995
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NON-PATENT DOCUMENTS

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